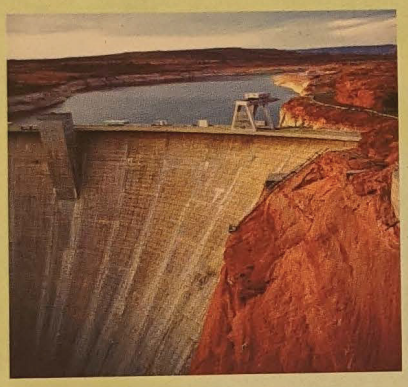
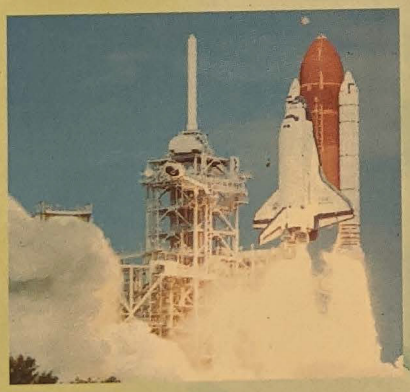
Current Trends in Engineering Practice

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CONTENTS

Foreword by R Natarajan v
Foreword by D V Singh vii
Preface ix
From the President's Desk xi

CIVIL ENGINEERING

Delhi Flyovers—On the Fast Track 3
Mahesh Tandon
Modern Techniques of Geotechnical Investigation 11
V. M. Sharma
In-Situ Characterisation of Rocks in the Himalayan Region 25
V. M. Sharma
Analysis and Instrumentation of Underground Structures 50
V. M. Sharma
GIS for Natural Resource Identification and Management 58
S. S. Chakraborty
Better-built Structures and Sustainability 77
S. S. Chakraborty
IT and GIS in Infrastructure Applications 86
S. S. Chakraborty

MECHANICAL ENGINEERING

Development of Non-conventional Energy Technologies 99
A. Ganguly
Productivity Management 110
A. Ganguly
Role of Earthmoving Equipment in Infrastructure Development Projects in India 119
K. Aprameyan
Effect of Process Parameters on Bond Strength and Wear Resistance of Thermally Sprayed Automotive Components 140
N. Gowrishankar
Piston Ring Materials and Processes For Enhanced Performance 149
N. Gowrishankar
Industrial Application of Robotics 159
S. R. Seetaram
Industrial Application of CAD-CAM 164
S. R. Seetaram

Industrial Application of Computers in Maintenance 171
S. R. Seetaram
Rubber Compounding Technology 177
R. Mukhopadhyay
Mixing Technology 186
R. Mukhopadhyay
Moulding Technology 198
R. Mukhopadhyay
Water Management in Industry 210
Tuhin K. Roy
Fluid Catalytic Cracking 224
Sobhan Ghosh
Steam Refining—Gasification and Syngas Production Technologies 241
Sobhan Ghosh
Refinery as a Source of Petrochemical Feedstock 253
Sobhan Ghosh

ELECTRICAL ENGINEERING

Partial Discharge Measurements 267
S. Gopal
High Voltage Measurement Techniques 282
S. Gopal
Electromagnetic Compatibility (EMC) and Electromagnetic Interference (EMI)—An Overview 298
S. Gopal
Power System Study/Planning Methodology 312
P. V. Bala Subramanyam
Generals about Power System Operations 315
P. V. Bala Subramanyam
Role of Power System Stabilizers In Power Systems 326
P. V. Bala Subramanyam

ELECTRONICS AND COMMUNICATION ENGINEERING

Optical Networking Overview: Trends/Technologies 339
V. Nagarajan
Spectrally Constrained Near-Nyquist Pulse Design 347
S. Jayasimha and P. K. Singh
Pragmatic TCM for 8-PSK in Satellite Communications 357
S. Jayasimha and P. Jyothendar

Photovoltaic UPS 367
S. Jayasimha and T. P. Kumar
Inertial Systems 379
S. N. Puri
Access Technologies 384
S. S. Shekhawat

AEROSPACE ENGINEERING

Prospects for Further Work in the Rotary Wing Field with Alh as the Catalyst 397
K. S. Sudheendra
Military Helicopters 403
K. S. Sudheendra
Quality and Reliability 407
K. Sudhakara Rao
Trajectory and Mission Design of Launch Vehicles 417
V. Adimurthy
Space Debris: Magnitude of the Problem and Engineering Solutions to Its Mitigation 437
V. Adimurthy
Re-entry of Objects from Geostationary Transfer Orbits 454
V. Adimurthy
Advances in Inertial Sensors and Systems 467
Amitava Bose
Navigation of Launch Vehicles 488
Amitava Bose
Redundancy Management of Inertial Systems 492
Amitava Bose
Modeling, Analysis & Design of Control for Launch Vehicles (Part-I) 502
S. Dasgupta

METALLURGY, MINING AND MATERIALS SCIENCE

Underground Coal Mining Technology in Coal India Limited Present and Future 527
N. K. Sharma
Selective Mining by Continuous Miner in Opencast Mines 538
N. K. Sharma
Prospects of Smelting Reduction Processes 549
Amit Chatterjee
Some Features of Iron-and-Steel making in Integrated Steel Plants 559
Amit Chatterjee
Trends in Production of Direct Reduced Iron with Particular Reference to India 582
Amit Chatterjee

ENERGY SYSTEMS AND ENGINEERING, NUCLEAR ENGINEERING

Coping With Time and Cost Over-runs In Project Management 599
Bhaskar Bose

MANAGEMENT

Corporate Turnaround—A Case Study of TVS Motor Company Limited 609
N. S. Mohan Ram
Structured New Product Development (NPD) Key to Quality Assurance and Effectiveness 613
N. S. Mohan Ram
Enhancing Productivity of Vehicle Fleets 624
Surjit Singh

dual tine concept. Further, Sunstrand design had metallic as well as fused quartz flexure cum proof mass depending on performance. Sunstrand brought out resonant beam accelerometer, typed as RBA 500 during 1991 for a larger application market and at a considerable low cost. RBA 500 has a bias error of <1mg, scale factor error of <360 ppm, power input 0f 0.1 watt, weighs 9 gm, operates between C–55°C to +80°C with a range of 70g and all at a cost of only Rs.0.4 lakh. A more accurate version called Superflex accelerometer which uses quartz flexure cum proof mass has a performance one order better. Singer Kearfott reported the qualification of one VBA with a range of 500g for strategic application. It has a bias error of 20 micro g and a scale factor error of 10 ppm, weighs 70gm.

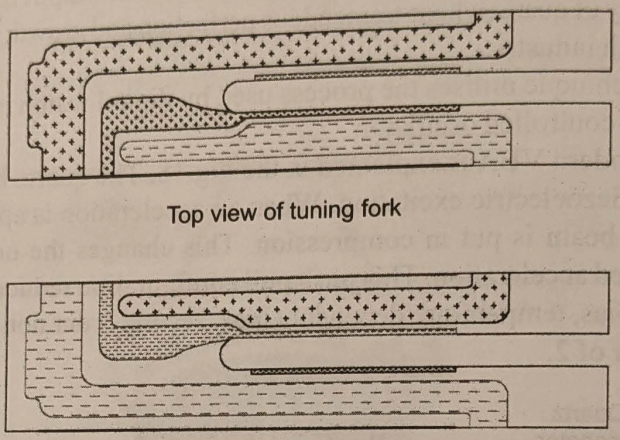


FIG. 19 TUNING FORK USED IN DIGITAL WATCH INDUSTRY WITH ELECTRODE PATTERN

Fig.20 shows electrode pattern of a dual tine resonator under development in ISRO.

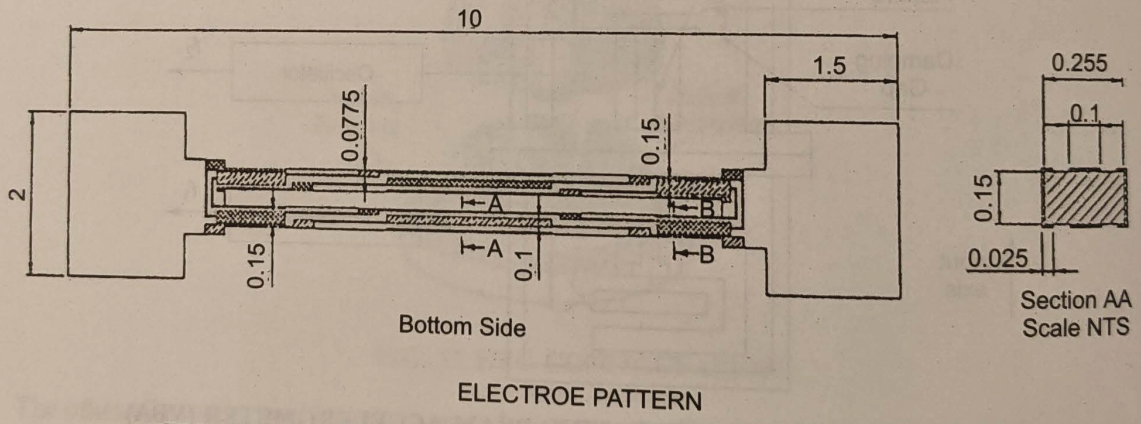


FIG. 20 TWO TINE QUARTZ BEAM WITH ELECTRODE PATTERN (UNDER DEVELOPMENT IN ISRO)

Quartz is not the only material for resonator, subsequent development at Sunstrand during 1995 used silicon beam with capacitive excitation and fabricated using silicon micro fabrication technique. This accelerometer reached performance required for 1 Nmph INS.

6. MICROMACHINED INERTIAL SENSORS

Micromachined inertial sensors use process technology such as 'Bulk micromachining' and 'Surface micromachining' developed by integrated circuit manufacturing industry and uses materials like mono

crystalline silicon, poly silicon and quartz to produce small sensors. Here, the motivating factors were substantial use of established facility and materials both of which witnessed tremendous growth during the last 30 years on account of electronic revolution. Force balance accelerometers, vibrating beam accelerometer and vibrating gyros of suitable shapes, are all amenable to micromachining.

Evolution

The first development of an open loop silicon accelerometer was reported in 1979 by Roylance and Angell. A partial application of this technology in gyro was reported by Systron Donner, USA during late eighties by bringing out Quartz Tuning fork gyro. During early part of ninety, Sunstrand, USA brought out quartz VBA in which the quartz beam alone was micromachined. During 1995, Allied Signal, USA reported all silicon VBA with navigation class performance. Draper lab, USA initiated [8] research on micromechanical sensors during 1985 and still continuing. It has reached 10°/hr class in gyro and 100 ug in accelerometer by now. Using these gyros and accelerometer, a very small (micro) IMU was realised which was integrated with a processor and GPS to guide a projectile fired from an artillery. Entire system was housed in 5 cm x 5 cm x 5 cm package. This IMU is shown in Fig.21. By 2005, an order improvement in performance is targetted with size reduced to 5 cm x 2 cm x 2 cm and price targetted for US $500.

Micromachined gyros and accelerometers development is actively funded for a vast range of application which could not be earlier thought off due to combined factors consisting of weight, size, cost and power. Diverse application such as Automotive, guided drilling, artillery shell guidance, personal navigator on soldier, spacecraft and unmanned micro air vehicle besides penetrating all the existing areas excepting where standalone high accuracy is required. In the medical field, these small gyros and accelerometers are planned to asist a person who has lost his balance due to some defect in the inside of the ear so that he can walk without falling. Due to such multifarious applications, research on MEMS technology is growing all over the industrialised world.

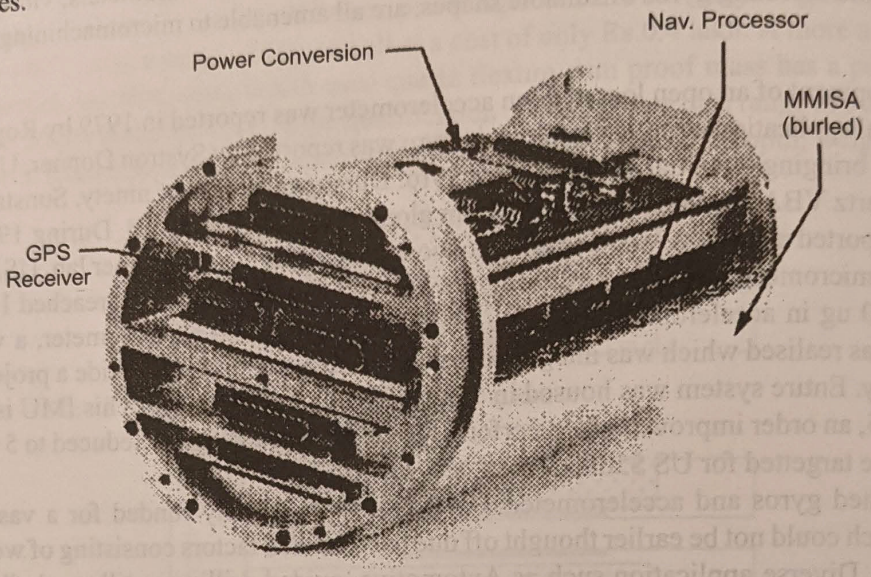
6.1 Multisensors

Considerable development effort is also going in the development of multisensors which combine rate and acceleration information in one sensor. SCIRAS is one such sensor reported in [7].

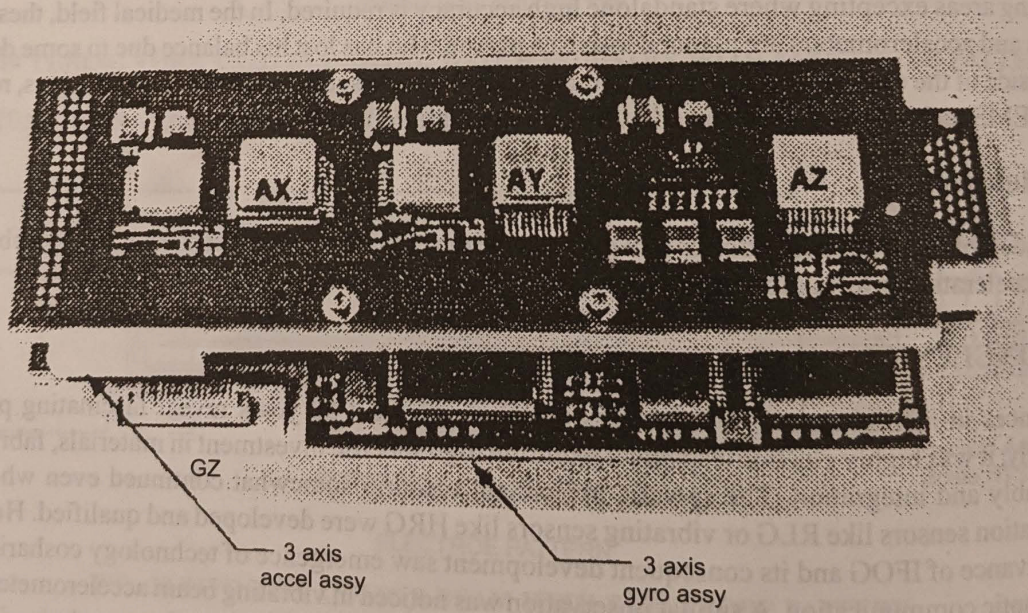
7. CONCLUSION

Advances in inertial sensors and systems during the the last 50 years reveal fascinating pictures. Initially, it was highly electromechanical requiring high specific investment in materials, fabrication, assembly and integration. The specific investment scenario somewhat continued even when later generation sensors like RLG or vibrating sensors like HRG were developed and qualified. However, the advance of IFOG and its consequent development saw emergence of technology cosharing with fiber optic communication. A similar observation was noticed in vibrating beam accelerometer where it co-shared with frequency standard and digital watch industry. Reduction of cost and viewing for a larger application market were the main driving forces behind the transition. Finally, the technology further took a turn with a view for substantial reduction in cost and weight in developing micromachining fabrication route to enable batch production. Also, it is seen that each technology had its specific problems which took a long time to solve but ultimately achieved very high performance and reliability. The advent of GPS or GLONASS is reorienting the decision making process on high accuracy sensors. Overall it can be seen that the research goal on cost, size, power and weight reduction in association

with the improvement in performance and reliability have been achieved in each of the new technologies. The micromachined sensors and systems are penetrating large application areas unthinkable in other technologies.



Integrated G & C MMISA



MMISA

FIG. 21 MICRO-MINIATURE INS WITH MEMS TECHNOLOGY

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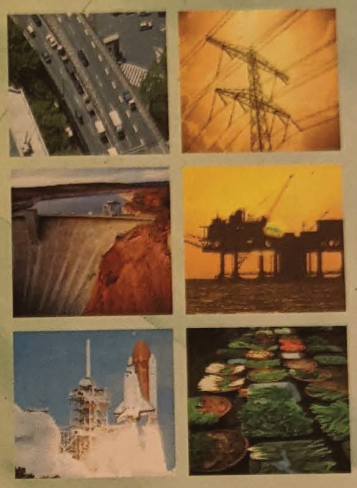

Editor
C V Ramakrishnan

Current Trends in Engineering Practices deals with recent engineering practices adopted in various projects in different engineering disciplines and specializations—Flyovers in Delhi, GIS applications, Geotechnical Investigations and structures, Construction of Earthmoving equipment, CAD CAM, Robotics, Automotive components, Rubber Technology, Fluid Catalytic Cracking, Syngas Production, High Voltage Measurement, Power System Methodologies, Optical Networks, Photovoltaic UPS, Inertial Systems, Access Technologies, Helicopter Technology, Launch Vehicle Design, Coal Mining, Iron and Steel making, New Product Development, Corporate Turnaround and Productivity of Vehicle Fleets.

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